

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/757,276
Filing Date January 14, 2004
Inventor Kevin L. Beaman et al.
Assignee..... Micron Technology, Inc.
Group Art Unit 2813
Examiner Stephen W. Smoot
Attorney's Docket No. MI22-2475
Customer No. 021567
Title: A Method of Forming a Structure Over a Semiconductor Substrate (as amended)

RESPONSE TO FEBRUARY 20, 2007 FINAL OFFICE ACTION
ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION (RCE)

To: Mail Stop: RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
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Responsive to the Final Office Action dated February 20, 2007, Applicant amends
and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.